

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit:	3753	:	
Examiner:	John A. Rivell	:	
In re Application of:		:	METHODS AND SYSTEMS FOR
		:	PERFORMING, MONITORING AND
		:	ANALYZING MULTIPLE MACHINE
John K. Apostolides		:	FLUID PROCESSES
Serial No.:	10/820,551	:	
Filing Date:	April 8, 2004	:	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

December 29, 2010

Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

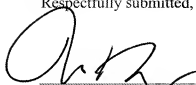
Dear Commissioner:

Applicant, in accordance with the duty of disclosure pursuant to 37 C.F.R. § 1.56, hereby advises the United States Patent and Trademark Office of the references listed on the accompanying form PTO/SB/08A *Information Disclosure Statement by Applicant*. A copy of each reference cited on the *Information Disclosure Statement by Applicant* is enclosed.

Applicant notes that although the cited references may be relevant to the examination of the above-referenced patent application, under 37 C.F.R. § 1.97(h), the filing of this *Information Disclosure Statement by Applicant* "shall not be construed to be an admission

that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b)."

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Michael D. Lazzara', is written over a horizontal line.

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